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ATTORNEY DOCKET NO.: 07553.0009

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

New U.S. Patent Application
Title: PLASMA PROCESSING METHOD
Inventor: Michiaki SANO

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. A check for \$1068 representing a \$1028 filing fee and \$40 for recording the Assignment.
2. Application - 17 pages, including 4 independent claims and 12 claims total.
3. Drawings - 6 sheets of formal drawings containing 10 figures.
4. Declaration and Power of Attorney.
5. Recordation Form Cover Sheet and Assignment to Tokyo Electron Limited.
6. Certified copy of Japanese Patent Application No. 11-276912, filed September 29, 1999.
7. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 1 document attached.

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Applicant claims the right to priority based on Japanese Patent Application No. 11-276912, filed September 29, 1999.

Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: David W. Hill
David W. Hill
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DWH/FPD/dvz
Enclosures